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Election
D Smalls-Logan
PATENT
Customer No. 22,852
Attorney Docket No. 03180.0289

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Masayuki TANAKA, et al.) Group Art Unit: 2823
)
Serial No.: 09/973,744) Examiner: Fourson III, George R.
)
Filed: October 11, 2001)
)
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE AND)
THE SEMICONDUCTOR DEVICE)

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In the Restriction Requirement dated November 1, 2002, with a period for response extending through January 2, 2003 (January 1st being a holiday) by the attached One-Month Petition for Extension of Time and requisite fee payment, the Examiner required further restriction under 35 U.S.C. § 121 between five separate Species. Applicants provisionally elect to prosecute the first Species, characterized by the Examiner as "wherein a metal nitride film is formed on the bottom and side wall of an insulating film patterned to expose a silicide film and a 10msec heating process using light whose main wavelength is shorter than a light absorbing end of silicon during a <600°C heating process followed by forming a contact conductor and wiring" (Restriction Requirement, p. 2). Applicants submit that claims 1 – 7 and 12 are readable thereon.

FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com

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Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: December 30, 2002

By: 

Richard V. Burgujian
Reg. No. 31,744

FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com